Notice of Allowability	Application No.	Applicant(s)		
	10/720,092	OKUMURA ET AL.		
	Examiner	Art Unit		
	Kin-Chan Chen	1765		
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1)  hereto or 2)  to Paper No./Mail Date	_	W (1 10 0 10) attached		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date		r in the Office action of		
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on t he header according to 37 Cl	he drawings in the front (not the l FR 1.121(d).	pack) of	
6. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT			ote the	
Attachment(s) 1. ⊠ Notice of References Cited (PTO-892)	5. ☐ Notice of Ir	nformal Patent Application (PTO	<b>-</b> 152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview S	6. ☐ Interview Summary (PTO-413),		
3. Information Disclosure Statements (PTO-1449 or PTO/SB/0	98), 7. Examiner's	Paper No./Mail Date 7.		
Paper No./Mail Date 122204 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material  8. ☑ Examiner's Statement of Reason 9. ☐ Other			s for Allowance	
		Kin-Chan Chen Primary Examiner Art Unit: 1765		



## **REASONS FOR ALLOWANCE**

1. The following is an examiner's statement of reasons for allowance:

The references of record do not teach or suggest a method comprising: using a microplasma generated at a pressure of not lower than 10,000Pa and not higher than three atmospheric pressures to the surface of the object; removing a natural oxide film, etching a region in which the natural oxide film has been removed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kin-Chan Chen whose telephone number is (571) 272-1461. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on (571) 272-1465. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you

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have questions on access to the Private PAIR system, contact the Electronic Business

Center (EBC) at 866-217-9197 (toll-free).

Kin-Chan Chen Primary Examiner Art Unit 1765

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